

Title (en)
DEVICE FOR CERAMIC-TYPE COATING OF A SUBSTRATE

Title (de)
VORRICHTUNG ZUR KERAMIKARTIGEN BESCHICHTUNG EINES SUBSTRATES

Title (fr)
DISPOSITIF DE REVETEMENT DE TYPE CERAMIQUE D'UN SUBSTRAT

Publication
EP 1360343 A1 20031112 (DE)

Application
EP 02701200 A 20020118

Priority
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Abstract (en)
[origin: DE10104611A1] Disclosed is a device for ceramic-type coating of a substrate (2), provided with means for applying a material (5, 7), especially by means of plasma (8), to the surface of the substrate (2), enabling ceramic coating (3) of relatively temperature-sensitive substrates (2) in comparison with prior art. This is achieved by providing an energy source, which is different from the source (4,6) of the material (5,7) which is provided for coating, for locally defined provision of energy to the material (3,5, 7, 8) disposed in front of/or on the surface.

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C23C 14/06

IPC 8 full level
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